The listing of claims will replace all prior versions, and listings, of claims in the application:

Listing of Claims:

1-34. (Canceled)

- 35. (Previously Presented) A display device comprising:
- a pair of filmy substrates facing each other;
- a thin film transistor formed over one of the pair of filmy substrates;
- a layer comprising a resinous material covering the thin film transistor; and
- a pixel electrode formed over the layer, and electrically connected to the thin film transistor.
 - 36. (Previously Presented) A display device comprising:
 - a pair of flexible substrates facing each other;
 - a thin film transistor formed over one of the pair of flexible substrates;
 - a layer comprising a resinous material covering the thin film transistor; and
- a pixel electrode formed over the layer, and electrically connected to the thin film transistor.

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- 37. (Currently Amended) A display device comprising:
- a pair of filmy substrates facing each other;
- a thin film transistor formed over one of the pair of filmy substrates;
- a silicon oxide film covering the thin film transistor, wherein the silicon oxide film is formed by applying a liquid; and

a pixel electrode formed over the [[layer]] silicon oxide film, and electrically connected to the thin film transistor.

- 38. (Currently Amended) A display device comprising:
- a pair of flexible substrates facing each other;
- a thin film transistor formed over one of the pair of flexible substrates;
- a silicon oxide film covering the thin film transistor, wherein the silicon oxide film is formed by applying a liquid; and
- a pixel electrode formed over the [[layer]] silicon oxide film, and electrically connected to the thin film transistor.
 - 39. (Previously Presented) A display device comprising:
 - a pair of filmy substrates facing each other;
 - a thin film transistor formed over one of the pair of filmy substrates;
 - a layer comprising a resinous material covering the thin film transistor; and
- a pixel electrode formed over the layer, and electrically connected to the thin film transistor,

wherein a resinous layer is provided on a surface of one of the pair of filmy substrates.

- 40. (Previously Presented) A display device comprising:
- a pair of flexible substrates facing each other;
- a thin film transistor formed over one of the pair of flexible substrates;
- a layer comprising a resinous material covering the thin film transistor; and
- a pixel electrode formed over the layer, and electrically connected to the thin film transistor.

wherein a resinous layer is provided on a surface of one of the pair of flexible and the state of the substrates.

- 41. (Currently Amended) A display device comprising:
- a pair of filmy substrates facing each other;
- a thin film transistor formed over one of the pair of filmy substrates;
- a silicon oxide film covering the thin film transistor, wherein the silicon oxide film is formed by applying a liquid; and
- a pixel electrode formed over the [[layer]] silicon oxide film, and electrically connected to the thin film transistor,

wherein a resinous layer is provided on a surface of one of the pair of filmy substrates.

- 42. (Currently Amended) A display device comprising:
- a pair of flexible substrates facing each other;
- a thin film transistor formed over one of the pair of flexible substrates;
- a silicon oxide film covering the thin film transistor, wherein the silicon oxide film is formed by applying a liquid; and
- a pixel electrode formed over the [[layer]] silicon oxide film, and electrically connected to the thin film transistor,

wherein a resinous layer is provided on a surface of one of the pair of flexible substrates.

- 43. (Previously Presented) A display device comprising:
- a pair of filmy substrates facing each other;
- a thin film transistor formed over one of the pair of filmy substrates, wherein the thin film transistor has a channel formation region comprising amorphous silicon;
 - a layer comprising a resinous material covering the thin film transistor; and
- a pixel electrode formed over the layer, and electrically connected to the thin film transistor.

wherein a resinous layer is provided on a surface of one of the pair of filmy substrates.

- 44. (Currently Amended) A display device comprising:
- a pair of flexible substrates facing each other;
- a thin film transistor formed over one of the pair of flexible substrates, wherein the thin film transistor has a channel formation region comprising amorphous silicon;
 - a layer comprising a resinous material covering the thin film transistor; and
- a pixel electrode formed over the layer, and electrically connected to the thin film transistor,

wherein a resinous layer is provided on a surface of one of the pair of [[filmy]] flexible substrates.

- 45. (Currently Amended) A display device comprising:
- a pair of filmy substrates facing each other;
- a thin film transistor formed over one of the pair of filmy substrates, wherein the thin film transistor has a channel formation region comprising amorphous silicon;
- a silicon oxide film covering the thin film transistor, wherein the silicon oxide film is formed by applying a liquid; and
- a pixel electrode formed over the [[layer]] silicon oxide film, and electrically connected to the thin film transistor,

wherein a resinous layer is provided on a surface of one of the pair of filmy substrates.

- 46. (Currently Amended) A display device comprising:
- a pair of flexible substrates facing each other;
- a thin film transistor formed over one of the pair of flexible substrates, wherein the thin film transistor has a channel formation region comprising amorphous silicon;

a silicon oxide film covering the thin film transistor, wherein the silicon oxide film is formed by applying a liquid; and

a pixel electrode formed over the [[layer]] silicon oxide film, and electrically connected to the thin film transistor,

wherein a resinous layer is provided on a surface of one of the pair of [[filmy]] flexible substrates.

- 47. (Previously Presented) A display device comprising:
- a pair of filmy substrates facing each other;
- a thin film transistor formed over one of the pair of filmy substrates, wherein the thin film transistor has a channel formation region comprising microcrystalline silicon;
 - a layer comprising a resinous material covering the thin film transistor; and
- a pixel electrode formed over the layer, and electrically connected to the thin film transistor.

wherein a resinous layer is provided on a surface of one of the pair of filmy substrates.

- 48. (Currently Amended) A display device comprising:
- a pair of flexible substrates facing each other;
- a thin film transistor formed over one of the pair of flexible substrates, wherein the thin film transistor has a channel formation region comprising microcrystalline silicon:
 - a layer comprising a resinous material covering the thin film transistor; and
- a pixel electrode formed over the layer, and electrically connected to the thin film transistor.

wherein a resinous layer is provided on a surface of one of the pair of [[filmy]] flexible substrates.

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- 49. (Currently Amended) A display device comprising:
- a pair of filmy substrates facing each other;
- a thin film transistor formed over one of the pair of filmy substrates, wherein the thin film transistor has a channel formation region comprising microcrystalline silicon;
- a silicon oxide film covering the thin film transistor, wherein the silicon oxide film is formed by applying a liquid; and
- a pixel electrode formed over the [[layer]] <u>silicon oxide film</u>, and electrically connected to the thin film transistor,

wherein a resinous layer is provided on a surface of one of the pair of filmy substrates.

- 50. (Currently Amended) A display device comprising:
- a pair of flexible substrates facing each other;
- a thin film transistor formed over one of the pair of flexible substrates, wherein the thin film transistor has a channel formation region comprising microcrystalline silicon;
- a silicon oxide film covering the thin film transistor formed, wherein the silicon oxide film is formed by applying a liquid; and
- a pixel electrode formed over the [[layer]] silicon oxide film, and electrically connected to the thin film transistor.

wherein a resinous layer is provided on a surface of one of the pair of [[filmy]] <u>flexible</u> substrates.

- 51. (Previously Presented) A display device comprising:
- a pair of filmy substrates facing each other;
- a thin film transistor formed over one of the pair of filmy substrates, wherein the thin film transistor has a channel formation region comprising crystalline silicon;
 - a layer comprising a resinous material covering the thin film transistor; and

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a pixel electrode formed over the layer, and electrically connected to the thin film transistor,

wherein a resinous layer is provided on a surface of one of the pair of filmy substrates.

- 52. (Currently Amended) A display device comprising:
- a pair of flexible substrates facing each other;
- a thin film transistor formed over one of the pair of flexible substrates, wherein the thin film transistor has a channel formation region comprising crystalline silicon;
 - a layer comprising a resinous material covering the thin film transistor; and
- a pixel electrode formed over the layer, and electrically connected to the thin film transistor,

wherein a resinous layer is provided on a surface of one of the pair of [[filmy]] flexible substrates.

- 53. (Currently Amended) A display device comprising:
- a pair of filmy substrates facing each other;
- a thin film transistor formed over one of the pair of filmy substrates, wherein the thin film transistor has a channel formation region comprising crystalline silicon;
- a silicon oxide film covering the thin film transistor, wherein the silicon oxide film is formed by applying a liquid; and
- a pixel electrode formed over the [[layer]] silicon oxide film, and electrically connected to the thin film transistor.

wherein a resinous layer is provided on a surface of one of the pair of filmy substrates.

54. (Currently Amended) A display device comprising:

a pair of flexible substrates facing each other;

a thin film transistor formed over one of the pair of flexible substrates, wherein the thin film transistor has a channel formation region comprising crystalline silicon;

a silicon oxide film covering the thin film transistor, wherein the silicon oxide film is formed by applying a liquid; and

a pixel electrode formed over the [[layer]] silicon oxide film, and electrically connected to the thin film transistor,

wherein a resinous layer is provided on a surface of one of the pair of [[filmy]] flexible substrates.

55. (Previously Presented) A display device comprising:

a pair of filmy substrates facing each other;

a thin film transistor formed over one of the pair of filmy substrates, wherein the thin film transistor has a channel formation region comprising crystalline silicon formed by irradiating an amorphous silicon film with a laser light;

a layer comprising a resinous material covering the thin film transistor; and

a pixel electrode formed over the layer, and electrically connected to the thin film transistor.

wherein a resinous layer is provided on a surface of one of the pair of filmy substrates.

56. (Currently Amended) A display device comprising:

a pair of flexible substrates facing each other;

a thin film transistor formed over one of the pair of flexible substrates, wherein the thin film transistor has a channel formation region comprising crystalline silicon formed by irradiating an amorphous silicon film with a laser light;

a layer comprising a resinous material covering the thin film transistor; and

a pixel electrode formed over the layer, and electrically connected to the thin film transistor.

wherein a resinous layer is provided on a surface of one of the pair of [[filmy]] flexible substrates.

- 57. (Currently Amended) A display device comprising:
- a pair of filmy substrates facing each other;
- a thin film transistor formed over one of the pair of filmy substrates, wherein the thin film transistor has a channel formation region comprising crystalline silicon formed by irradiating an amorphous silicon film with a laser light;
- a silicon oxide film covering the thin film transistor, wherein the silicon oxide film is formed by applying a liquid; and
- a pixel electrode formed over the [[layer]] silicon oxide film, and electrically connected to the thin film transistor,

wherein a resinous layer is provided on a surface of one of the pair of filmy substrates.

- 58. (Currently Amended) A display device comprising:
- a pair of flexible substrates facing each other;
- a thin film transistor formed over one of the pair of flexible substrates, wherein the thin film transistor has a channel formation region comprising crystalline silicon formed by irradiating an amorphous silicon film with a laser light;
- a silicon oxide film covering the thin film transistor, wherein the silicon oxide film is formed by applying a liquid; and
- a pixel electrode formed over the [[layer]] <u>silicon oxide film</u>, and electrically connected to the thin film transistor,

wherein a resinous layer is provided on a surface of one of the pair of [[filmy]] flexible substrates.

- 59. (Previously Presented) A display device according to any one of claims 55-58, wherein the laser light comprises at least one selected from the group consisting of KrF excimer laser light and XeCl laser light.
- 60. (Previously Presented) A display device according to any one of claims 39-58, wherein the resinous layer comprises an acrylic resin.
- 61. (Previously Presented) A display device according to any one of claims 39-58, wherein the resinous layer comprises at least one selected from the group consisting of methyl esters of acrylic acid, ethyl esters of acrylic acid, butyl esters of acrylic acid, and 2-ethylhexyl esters of acrylic acid.
- 62. (Currently Amended) A display device according to any one of claims 35, 37, 39, 41, 43, 45, 47, 49, 51, 53, 55 and 57, wherein the filmy substrate comprises pair of filmy substrates comprise at least one selected from the group consisting of PET (polyethylene terephthalate), PEN (polyethylene naphthalate), PES (polyethylene sulfite), and polyimide.
- 63. (Currently Amended) A display device according to any one of claims 35, 37, 39, 41, 43, 45, 47, 49, 51, 53, 55 and 57, wherein the filmy substrate comprises a plastic substrate pair of filmy substrates comprise plastic substrates.
- 64. (Currently Amended) A display device according to any one of claims 36, 38, 40, 42, 44, 46, 48, 50, 52, 54, 56 and 58, wherein the flexible substrate comprises a plastic substrate pair of flexible substrates comprise plastic substrates.
- 65. (Currently Amended) A display device according to any one of claims 36, 38, 40, 42, 44, 46, 48, 50, 52, 54, 56 and 58, wherein the flexible substrate comprises

pair of flexible substrates comprise at least one selected from the group consisting of PET (polyethylene terephthalate), PEN (polyethylene naphthalate), PES (polyethylene sulfite), and polyimide.

- 66. (Previously Presented) A display device according to any one of claims 35-58, wherein the thin film transistor comprises a coplanar thin-film transistor.
- 67. (Previously Presented) A display device according to any one of claims 35-58, wherein the thin film transistor comprises an inverted-staggered thin-film transistor.